

OCT 0 8 26.00 TC 1700

THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No. 2001-0660A

Norio KIMURA et al.

Confirmation No. 1632

Serial No. 09/864,208

Group Art Unit 1763

Filed May 25, 2001

Examiner Sylvia MacArthur

SUBSTRATE POLISHING APPARATUS AND SUBSTRATE POLISHING METHOD

1

SUBMISSION OF FORMAL DRAWINGS

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Enclosed is 1 sheet of formal (A-4) drawing (Fig. 4) submitted herewith.

Respectfully submitted,

Norio KIMURA et al

By:

Nils E. Pedersen

Registration No. 33,145

Attorney for Applicants

NEP/krg

Washington, D.C. 20006-1021

Telephone: (202) 721-8200

Facsimile: (202) 721-8250

October 6, 2003

THE COMMISSIONER IS AUTHORIZED TO CHADAL ANY DESCRIPTION OF IN THE FEES FOR THIS PAPER TO DEPOSIT

ACCOUNT NO. 23-0975